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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Chirag S. PATEL CONFIRMATION NO.: 4661
SERIAL NO.: 10/674,331 ART UNIT: 2815
FILED: 09/30/2003 EXAMINER: Chris C. CHU
TITLE: FABRICATION OF SEMICONDUCTOR DIES WITH MICRO-PINS
AND STRUCTURES PRODUCED THEREWITH

ATTORNEY DOCKET NO.: YOR920030139US1

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

In response to the Office Action mailed on January 26, 2005, please reconsider this application in response to the following:

Amendments to Specification	Page 2
Listing of and amendment to claims	Page 4
Remarks (including election)	Page 9
Formal Drawings - Attached	17 Sheets

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

APRIL 26, 2005
Date

David Ober
Name of Person Making Deposit